



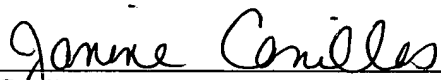
DOCKET NO: VSEA 009-00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Joseph C. Olson et al.
Serial No: 09/826,274
Confirmation No: 2953
Filed: April 4, 2001
For: CATHODE ASSEMBLY FOR INDIRECTLY HEATED
CATHODE ION SOURCE
Examiner: Dalei Dong
Art Unit: 2879

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Janine Canillas

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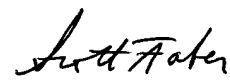
Sir:

Transmitted herewith are the following documents:

- [X] Amendment
- [X] Petition for Extension of Time
- [X] Return Receipt Postcard

If any additional fees are determined to be required or if there are any overpayments, Deposit Account 50-0896 may be charged or credited. A duplicate of this sheet is enclosed.

Respectfully submitted,
Joseph C. Olson et al., Applicants

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